

PATENT NUMBER

U.S. UTILITY Patent Application

O.I.P.E.	PATENT DATE
SCANNED <u>Ct³ on 11/11</u>	

APPLICATION NO. 09/519599	CONT/PRIOR F	CLASS 257 439	SUBCLASS 153	ART UNIT 2814	EXAMINER T. QUACH RETRACTA
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Kazuo Maeda

Method and apparatus for forming an ohmic contact, insulating film and semiconductor device

PTO-2040
(2/99)[illegible]

Form PTO-436A
(Rev. 5/80)

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